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Substitute for form 1449B/PTO				<b>Complete if Known</b>	
				<i>Application Number</i>	10/812,492
				<i>Filing Date</i>	March 30, 2004
				<i>First Named Inventor</i>	Walter E. Donovan
				<i>Art Unit</i>	2676
				<i>Examiner Name</i>	Unknown
Sheet	1	of	1	<i>Attorney Docket Number</i>	NVDA P000850

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials *	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		T <sup>2</sup>
MR		McCormack, Joe, et al., "Feline: Fast Elliptical Lines for Anisotropic Texture Mapping," Mitsubishi Electric Information Technology Center America, 2000.		
MR		Greene, Ned, et al., "Creating Raster Omnimax Images from Multiple Perspective Views Using the Elliptical Weighted Average Filter," IEEE Computer Graphics and Applications, Vol. 6, Issue 6, pp. 21-27, June 1986.		
MR		Williams, Lance, "Pyramidal Parametrics," Computer Graphics, Vol. 17, No. 3, July 1983.		
MR		Heckbert, Paul S., "Fundamentals of Texture Mapping and Image Warping," Master's Thesis, Dept. of Electrical Engineering and Computer Science, University of California, Berkeley, CA, June 17, 1989.		
MR		"ATI's Optimized Texture Filtering Called Into Question," Tom's Hardware Guide, December 17, 2004. < <a href="http://www20.graphics.tomshardware.com/graphic/20040603/index.html">http://www20.graphics.tomshardware.com/graphic/20040603/index.html</a> >		
MR		Heckbert, Paul, "Texture Mapping Polygons In Perspective," Computer Graphics Lab, New York Institute of Technology, Technical Memo No. 13, April 28, 1983.		

Examiner Signature	/Manucher Rahmjoo/ (07/06/2006)	Date Considered	07/06/2006
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